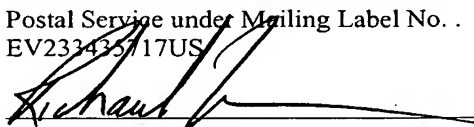


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Min Ho Jung et al.)	I hereby certify that this Continuing
)	Application Transmittal and the
Serial No.: To be assigned)	documents referred to as enclosed
)	therewith are being deposited with the
Filed: February 27, 2004 (Herewith))	United States Postal Service on
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)	Alexandria, Virginia 22313-1450,
Group Art Unit: To be assigned)	utilizing the "Express Mail Post Office to
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)	Richard Zimmermann

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please enter the following preliminary amendment in the above-referenced
divisional application.